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|---|-------------------------------------|-----------------------------|-----------------------------------|-----------|-------------------|
| AMENDMENT TRANSMITTAL LETTER (Large Entity) Applicant(s): Hirohiko Nishiki | | | Docket No. SLA0454 | | |
| Serial No 10/021,342 | Filing Date December 12, 2001 | Examiner T. R. Chowdhury | Group Art Unit 2871 | | |
| Invention: System and Method for Forming Ozone Resistant IC and LCD Structures (as amended) | | | | | |
| TO THE COMMISSIONER FOR PATENTS: | | | | | |
| Transmitted herewith is an amendment in the above identified application. The fee has been calculated and is transmitted as shown below. | | | | | |
| CLAIMS AS AMENDED | | | | | |
| | CLAIMS REMAINING AFTER AMENDMENT | HIGHEST # PREV. PAID FOR | NUMBER OF EXTRA CLAIMS PRESENT | RATE | ADDITIONAL FEE |
| TOTAL CLAIMS | 15 - | 29 = | 0 | x \$18.00 | \$00.00 |
| INDEP. CLAIMS | 6 - | 7 = | 0 | x \$84.00 | \$0.00 |
| Multiple Dependent Claims (check if applicable) _____ | | | | | \$0.00 |
| TOTAL ADDITIONAL FEE FOR THIS AMENDMENT | | | | | \$00.00 |

☒ No additional fee is required.

_____ Please charge Deposit Account No. _____ in the amount of _____

_____ A duplicate copy of this sheet is enclosed.

_____ A check in the amount of _____ to cover the filing fee is enclosed.

☒ The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. . 19-1457.

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☒ Any additional fees required under 37 C.F.R. 1.16.

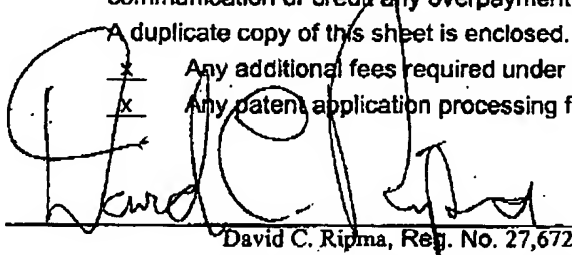
☒ Any patent application processing fees under 37 C.F.R. 1.17.

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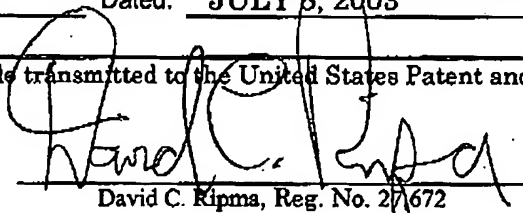
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Dated: JULY 8, 2003


 David C. Ripma, Reg. No. 27,672

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office under 37 C.F.R. §1.8 at Fax No. (703) 872-9318 on July 8, 2003.


 David C. Ripma, Reg. No. 27,672

Note: Each paper must have its own certificate or transmission, or this certificate must identify each submitted paper. The papers submitted include:

| | |
|--|------------|
| <input checked="" type="checkbox"/> This Amendment Transmittal Letter (Duplicate Attached) | 2 page(s) |
| <input checked="" type="checkbox"/> Response under 37 CFR § 1.111 | 12 page(s) |
| _____ Attachments | page(s) |
| _____ Petition for Extension of Time under 37 C.F.R. § 1.136 (Duplicate Attached) | page |

Total pages, including this Transmittal: 14

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

7/11/03

| | | |
|------------------------------|---|-------------------|
| In Re Application of: |) | |
| |) | |
| Inventors: Hirohiko Nishiki |) | |
| |) | |
| Serial No.: 10/021,342 |) | ATTORNEY FILE NO. |
| |) | SLA 454 |
| Filed: December 12, 2001 |) | |
| |) | |
| Title: SYSTEM AND METHOD FOR |) | |
| FORMING OZONE |) | |
| RESISTANT IC AND LCD |) | |
| STRUCTURES (as amended) |) | |
| |) | |

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Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND REQUEST FOR RECONSIDERATION

In response to an Office Action filed June 11, 2003, please
amend and reconsider as follows.